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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/862,458	05/23/2001	Masahiko Tanaka	001425-104 7476		
21839	21839 7590 01/25/2006		EXAMINER		
BUCHANAN INGERSOLL PC (INCLUDING BURNS, DOANE, SWECKER & MATHIS) POST OFFICE BOX 1404 ALEXANDRIA, VA 22313-1404			MOORE, KARLA A		
			ART UNIT	PAPER NUMBER	
			1763		

DATE MAILED: 01/25/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

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· Office Assistant Communication		Арриса	tion No.	Applicant(s)			
		09/862,	458	TANAKA ET AL.			
Office Action Summary			er	Art Unit			
		Karla Me		1763			
Period fo	The MAILING DATE of this communic or Reply	cation appears on t	he cover sheet with the	correspondence ad	ddress		
WHIC - Exter after - If NO - Failu Any r	ORTENED STATUTORY PERIOD FO CHEVER IS LONGER, FROM THE MA asions of time may be available under the provisions of SIX (6) MONTHS from the mailing date of this commu- period for reply is specified above, the maximum state re to reply within the set or extended period for reply we reply received by the Office later than three months afted patent term adjustment. See 37 CFR 1.704(b).	AILING DATE OF Tof 37 CFR 1.136(a). In no currication. tutory period will apply and will, by statute, cause the a	THIS COMMUNICATIO event, however, may a reply be ti will expire SIX (6) MONTHS from pplication to become ABANDON	N. mely filed n the mailing date of this of ED (35 U.S.C. § 133).	•		
Status							
1)[X]	Responsive to communication(s) filed	d on 16 November	2005				
· -	Responsive to communication(s) filed on <u>16 November 2005</u> . This action is FINAL . 2b) This action is non-final.						
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is						
٠,٠	closed in accordance with the practic	•	· •				
Dispositi	on of Claims	•	,				
		nding in the applica	tion				
	Claim(s) <u>1-4,6,9-26 and 28</u> is/are pending in the application. 4a) Of the above claim(s) is/are withdrawn from consideration.						
	Claim(s) is/are allowed.	· · · · · · · · · · · · · · · · · · ·					
· —	Claim(s) <u>1-4,6,9-26 and 28</u> is/are reje	ected.					
	Claim(s) is/are objected to.						
	Claim(s) are subject to restrict	ion and/or election	requirement				
	· · · · · · · · · · · · · · · · · · ·		, oqui, omonii				
	on Papers						
· · · ·	The specification is objected to by the		_				
10)[The drawing(s) filed on is/are:	•					
	Applicant may not request that any object		· ·				
	Replacement drawing sheet(s) including t	•	Ŧ · ·	-	• •		
11)	The oath or declaration is objected to	by the Examiner. N	Note the attached Office	e Action or form P	ΓO-152.		
Priority u	ınder 35 U.S.C. § 119						
_	Acknowledgment is made of a claim fo ⊠ All b)□ Some * c)□ None of:	or foreign priority u	nder 35 U.S.C. § 119(a)-(d) or (f).			
	1. Certified copies of the priority d	documents have be	en received.				
	2. Certified copies of the priority d			ion No			
	3. Copies of the certified copies o	of the priority docun	nents have been receiv	ed in this National	Stage		
	application from the Internation	al Bureau (PCT Ri	ıle 17.2(a)).				
* S	ee the attached detailed Office action	for a list of the cer	tified copies not receive	ed.			
				•			
Attachment	c(s)						
	e of References Cited (PTO-892)		4) Interview Summary				
_	e of Draftsperson's Patent Drawing Review (PT	-	Paper No(s)/Mail D 5) Notice of Informal F		O-152)		
	nation Disclosure Statement(s) (PTO-1449 or P r No(s)/Mail Date	~1O/SB/08)	6) Other:	atent Application (PT)	J-1J2)		

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DETAILED ACTION

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 1, 4, 9, 14-15, 20-24, 26 and 28 are rejected under 35 U.S.C. 103(a) as being unpatentable over Japanese Patent No. 11-168094A to Yuda in view of U.S. Patent No. 6,086,677 to Umotoy et al. and U.S. Patent No. 5,102,523 to Beisswenger et al.
- 3. Yuda et al. disclose the invention substantially as claimed in Figure 1 and comprising: a vacuum reaction chamber (Figure 1, 16) and a electrically conducting dividing plate/dividing means (Figures 8-10, 26; paragraph 43 of JPO online translation), the vacuum reaction chamber is divided into a plasma discharge space (Figure 8, above the plate) and a film deposition process space (Figure 8, below the plate), the dividing plate having a plurality of internal spaces (27) and a plurality of holes (30) therein, the internal spaces are connected with the film deposition process space, the plurality of holes connect the plasma discharge space with the film deposition process space, and a plasma is used to generate radicals in the plasma discharge space, which radicals are introduced into the said film deposition process space through the plurality of holes in the dividing plate, and a precursor gas (9) is directly introduced into the film deposition process space react together to deposit a film (4) on a substrate (3) disposed in the film deposition process space, the dividing plate is constructed so as to separate the radicals generated in the plasma discharge space from the precursor gas while the precursor gas is in the internal spaces.
- 4. However, Yuda et al. fail to teach the dividing plate is made of a plurality of plates connected together by securely bonding them over substantially an entire area of their interfacial surfaces.
- 5. Umotoy et al. teach using a plurality of plates as a way to maintain gases in separate passages of

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a distribution plate until they exit the distribution plate into the process region (column 1, row 64 through column 2, row 5). Umotoy et al. further teach fusing together a plurality of laminated plates at their contacting surfaces for the purpose of avoiding the use of o-rings while maintaining separation of gases as gases transition from the upper plate to the lower plate (column 3, rows 33-44 and column 5, rows 5-15). Also see column 7, rows 40-47.

- 6. It would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to have provided a plurality of laminated plates fused together at their contacting surfaces in Yuda et al. in order to maintain gases in separate passageways until they exit the distribution plate into the process region and in order to avoid the use of o-rings while maintaining a separation of gases as the gases transition form an upper plate to a lower plate as taught by Umotoy et al.
- 7. Yuda et al. and Umotoy et al. disclose the invention substantially as claimed and described above.
- 8. However, Yuda et al. and Umotoy et al. fail to teach the dividing plate is arranged in the vacuum reaction chamber such that the only communication between the plasma discharge space and the film deposition process space is through the plurality of holes.
- 9. Beisswenger et al. teach a dividing plate and accompanying seals (Figure 1, 65 and 66) to seal the dividing plate and adjacent spaces within a vacuum chamber for the purpose of preventing gases from escaping upwards (column 4, rows 57-62).
- 10. It would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to have provided seals for arranging the dividing plate such that the only communication between the plasma discharge space and the film deposition process space is through the plurality of holes in Yuda et al. and Umotoy et al. in order to prevent gases from escaping upwards as taught by Beisswenger et al.
- 12. Yuda et al., Umotoy et al. and Beisswenger et al. disclose the invention substantially as claimed and as described above.
- 13. However, as described above Yuda et al., Umotoy et al. and Beisswenger et al. fail to teach a

plurality of holes formed to satisfy the condition uL/D>1, where u is the gas flow rate inside the holes, L is the effective length of the holes and D is the diffusion coefficient.

- 14. Umotoy et al. do however teach that the choice of hole size for each gas is purely a process condition and as such, hole size will depend on gas flow rate, gas pressure, gas type, chamber pressure and the like (column 5, rows 37-43).
- 15. It would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to find an optimum gas hole configuration in Yuda et al., Umotoy et al. and Beisswenger et al. based on conditions of each individual process as taught by Umotoy et al.
- 16. Further, the courts have ruled where the general conditions of a claim are disclosed by the prior art, it is not inventive to discover the optimum or workable ranges by routine experimentation. In re Aller, 220 F.2d 454, 456, 105 USPQ 233, 2235 (CCPA 1955).
- 17. With respect to claims 4, 14, 20, 22-23 and 26, as noted above, the dividing plate is made by connecting together a plurality of laminated plates by securely bonding them ever the entire area of their interfacial surfaces (this includes the outer periphery and portions that are within the outer periphery, as recited in claim 9). Additionally, the plurality of holes provided in the dividing plate is formed by piercing through it at positions where the internal spaces are not disposed (i.e. they do not overlap).
- 18. With respect to claims 9, 15, 21, 24, Yuda et al. teach that the dividing plate is an electrode, so it would inherently be made of electrically conductive material.
- 19. With respect to claim 28, as noted above, the dividing plate of Yuda et al. comprises a plurality of internal spaces.
- 20. Claims 10-11 and 16-17 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yuda et al., Umotoy et al. and Beisswenger et al. as applied to claims 1, 4, 9, 14-15, 20-24, 26 and 28 above, and further in view of U.S. Patent No. 5,433,786 to Hu et al.
- 21. Yuda et al., Umotoy et al. and Beisswenger et al. disclose the invention substantially as claimed

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and as described above.

21. However, Yuda et al., Umotoy et al. and Beisswenger et al. fail to teach the plurality of plates bonded together by a plurality of rivets or threaded fasteners.

- 22. Hu et al. teach the use of rivets and other suitable fastening means for the purpose of assembling an electrode (column 3, rows 53-56).
- 23. It would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to have provided rivets or other suitable fastening means in Yuda et al., Umotoy et al. and Beisswenger et al. in order to assemble the dividing plate/electrode as taught by Hu et al. Further, the courts have ruled that an express suggestion to substitute one equivalent component or process for another is not necessary to render such substitution obvious. In re Fout, 675 F.2d 297, 213 USPQ 532 (CCPA 1982).

Allowable Subject Matter

- 24. Claims 2 and 6 are allowed.
- 25. The following is an examiner's statement of reasons for allowance: The prior art presented above fails to teach or fairly suggest a plurality of metal fixings (either rivets or threaded parts) to securely bond the laminated plates over the entire area of their interfacial surfaces, and the plurality of holes provided in the dividing plate are provided through the metal fixings. Additionally, no other prior art reference provides motivation for the feature.
- 26. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."
- 27. Claims 3, 7, 12-13, 18-19 and 25 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
- 28. The prior art presented above fails to teach or fairly suggest a plurality of metal fixings (either rivets or threaded parts) to securely bond the laminated plates over the entire area of their interfacial surfaces, and the plurality of holes provided in the dividing plate are provided through the metal fixings.

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As noted above, no other prior art reference provides motivation for the feature.

Response to Affidavit

29. The declaration filed under 37 CFR 1.132 filed 15 November 2005 is insufficient to overcome the rejection of claims 1, 4, 5, 8-11, 14-17, 20-24 and 26-28 based upon the rejections using Yuda, Umotoy et al. and Beisswenger et al. as set forth in the last Office action because:

- 30. With respect to Mr. Nogami's opinion that there is not a teaching in Yuda that would suggest one to avoid the use of o-rings as suggested by Umotoy, Examiner notes that the rejection is based on motivation disclosed in Umotoy et al. It is not necessary for both of the references to provide motivational statements. It is sufficient that Umotoy et al provides motivation.
- 31. With respect to Mr. Nogami's opinion that there would be no motivation to provide seals as claimed based on the disclosure of Beisswenger et al. Examiner disagrees and points out that Beisswenger et al. is relied upon for teaching providing seals adjacent a dividing plate for the purpose of keeping adjacent spaces separate. Examiner did not and does not suggest that Beisswenger et al. explicitly discloses a plasma discharge space and a film deposition process space exactly as recited in the claims. What Beisswenger et al. do suggest however is that in an apparatus where a dividing plate is used to maintain two separate spaces (as disclosed in Yuda and Umotoy) -- providing seals can to help maintain and/or ensure separation. Obviously, gas migrating in any direction (for example upwards) would be related to the issue because if gas is migrating from one space to another the separation is not being maintained.
- 32. With respect to Mr. Nogami's opinion that Umotoy does not teach choosing a hole size based on process conditions, Examiner disagrees. This teaching is clearly disclosed at column 5, rows 37-43.
- 33. In view of the foregoing, when all of the evidence is considered, the totality of the rebuttal evidence of nonobviousness fails to outweigh the evidence of obviousness.

Response to Arguments

34. Applicant's arguments presented in submissions filed on 15 November 2005 with respect to claims 1, 4, 5, 8-11, 14-17, 20-24 and 26-28 have been considered but they are not convincing.

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- 35. Applicant's argument that the mesh electrode 8 or 11 of Yuda is not disclosed as the dividing plate is claimed is immaterial because this is not the structure relied upon in the rejections above as representing the dividing plate. The dividing plate (Figures 8-10, 26) of Yuda is in fact a dividing plate that provides for communication between two adjacent spaces through a plurality of holes only, as claimed.
- 36. With respect to the argument that there is not a teaching in Yuda that would suggest one to avoid the use of o-rings as suggested by Umotoy, Examiner notes that the rejection is based on motivation disclosed in Umotoy et al. It is not necessary for both of the references to provide motivational statements. It is sufficient that Umotoy et al provides motivation.
- 37. With respect to argument that Umotoy does not teach choosing a hole size based on process conditions, Examiner disagrees. This teaching is clearly disclosed at column 5, rows 37-43. Examiner also submits that the Umotoy and the Yuda function sufficiently the same in that they are both concerned with delivering a gas to a substrate to perform a processing method.
- 38. With respect to Applicant's argument that there is no teaching in Yuda that would suggest one to avoid the use of o-rings as suggested by Umotoy, Examiner notes that the rejection is based on motivation disclosed in Umotoy et al. It is not necessary for both of the references to provide motivational statements. It is sufficient that Umotoy et al provides motivation.
- 39. With respect to Applicant's argument that there would be no motivation to provide seals as claimed based on the disclosure of Beisswenger et al. Examiner disagrees and points out that Beisswenger et al. is relied upon for teaching providing seals adjacent a dividing plate for the purpose of keeping adjacent spaces separate. Examiner did not and does not suggest that Beisswenger et al. explicitly discloses a plasma discharge space and a film deposition process space exactly as recited in the claims. What Beisswenger et al. does suggest however is that in an apparatus where a dividing plate is used to maintain two separate spaces (as disclosed in Yuda and Umotoy) -- providing seals can to help maintain and/or ensure separation. Obviously, gas migrating in any direction (for example upwards) would is related to the issue because if gas is migrating from one space to another the separation is not being maintained.
- 40. In response to applicant's argument that the examiner's conclusion of obviousness is based upon

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improper hindsight reasoning, it must be recognized that any judgment on obviousness is in a sense

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necessarily a reconstruction based upon hindsight reasoning. But so long as it takes into account only

knowledge which was within the level of ordinary skill at the time the claimed invention was made, and

does not include knowledge gleaned only from the applicant's disclosure, such a reconstruction is proper.

See In re McLaughlin, 443 F.2d 1392, 170 USPQ 209 (CCPA 1971).

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should

be directed to Karla Moore whose telephone number is 571.272.1440. The examiner can normally be

reached on Monday-Friday, 9:00 am-6:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor,

Parviz Hassanzadeh can be reached on 571.272.1435. The fax phone number for the organization

where this application or proceeding is assigned is 571-273-8300.

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you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC)

at 866-217-9197 (toll-free).

Karla Moore Patent Examiner Art Unit 1763

22 January 2006